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**PATENT APPLICATION**

**RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 2653**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Ikuhito ONODERA

Group Art Unit: 2653

Application No.: 10/076,653

Examiner: C. MAGEE

Filed: February 19, 2002

Docket No.: 111984

For: METHOD FOR FABRICATING A THIN FILM MAGNETIC HEAD AND WAFER  
STRUCTURE

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the July 14, 2005, Office Action, please consider the following:

**Amendments to the Specification;**

**Remarks.**